
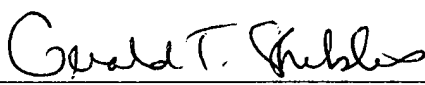
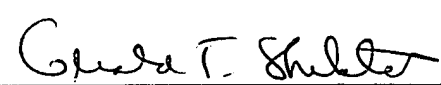


AMENDMENT TRANSMITTAL LETTER (Large Entity)			Docket No. 82822		
Applicant(s): Nakamura et al.					
Serial No. 09/856,209	Filing Date May 18, 2001	Examiner Matthew J. Song		Group Art Unit 1765	
Invention: SILICON CRYSTAL AND PRODUCTION METHOD FOR SILICON SINGLE CRYSTAL WAFER					
 <u>TO THE COMMISSIONER FOR PATENTS:</u>					
Transmitted herewith is an amendment in the above-identified application.					
The fee has been calculated and is transmitted as shown below.					
CLAIMS AS AMENDED					
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	2 -	20 =	0 x	\$18.00	\$0.00
INDEP. CLAIMS	2 -	3 =	0 x	\$86.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00
<p> <input checked="" type="checkbox"/> No additional fee is required for amendment. <input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of _____ <input type="checkbox"/> A check in the amount of _____ to cover the filing fee is enclosed. <input checked="" type="checkbox"/> The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 23-0920 <input checked="" type="checkbox"/> Any additional filing fees required under 37 C.F.R. 1.16. <input checked="" type="checkbox"/> Any patent application processing fees under 37 CFR 1.17. </p>					
 _____ <i>Signature</i>			Dated: April 30, 2004		
Gerald T. Shekleton WELSH & KATZ, LTD. 120 South Riverside Plaza 22nd Floor Chicago, Illinois 60606 (312) 655-1500			I certify that this document and fee is being deposited on April 30, 2004 with the U.S. Postal Service as first class mail under 37C.F.R. 1.8 and is addressed to the for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.  <i>Signature of Person Mailing Correspondence</i> Gerald T. Shekleton <i>Typed or Printed Name of Person Mailing Correspondence</i>		
CC:					

RCE
1765

IPW



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application

Applicant: Kozo Nakamura

Serial No.: 09/856,209

Filed: May 18, 2001

For: **SILICON CRYSTAL AND
PRODUCTION METHOD FOR
SILICON SINGLE CRYSTAL
WAFER**

Examiner: Matthew J. Song

) Art Unit: 1765

)

) Confirmation No.: 6736

)

) *I hereby certify that this correspondence is
being deposited with the United Postal
Service as first class mail in an envelope
addressed to: Mail Stop RCE,
Commissioner for Patents / PO Box 1450 /
Alexandria, Virginia 22313-1450, on April
30, 2004:*

)

) *Gerald T. Shekleton*

) *Gerald T. Shekleton Reg. No. 27,466*

)

SUPPLEMENTAL AMENDMENT

Mail Stop RCE
Commissioner for Patents
PO Box 1450
Alexandria, Virginia 22313-1450

Sir:

Please make the following amendments in conjunction with the recently filed Request for Continued Examination.